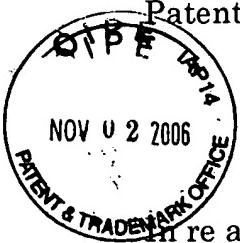


*ZJW*

Patent Application No. 10/599,544

Attorney Docket No. 81872.0129  
Customer No.: 26021



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Youhei SAKAI

Serial No: 10/599,544

Filed: September 29, 2006

For: SILICON CASTING APPARATUS AND  
METHOD OF PRODUCING SILICON  
INGOT

Art Unit: Not assigned

Examiner: Not assigned

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: MAIL STOP AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450
October 30, 2006
Date of Deposit
Judy Bacchi
Name
<i>Judy Bacchi</i>
Signature
10/30/2006
Date

**SECOND PRELIMINARY AMENDMENT**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

Prior to the first Office Action in the present application, please enter and consider the following amendments and remarks:

**Amendments to the specification begin on page 2 of this paper.**

**Remarks/Arguments begin on page 3 of this paper.**